

First Named Inventor	Chun Chen	GENERAL TRANSMITTAL FORM UNDER 37 CFR 1.8 (LARGE ENTITY)
Serial No.	10/714,752	
Filing Date	November 17, 2003	
Group Art Unit	Unknown	
Examiner Name	Unknown	
Confirmation No.	Unknown	
Attorney Docket No.	400.235US01	
Title: METHOD FOR FORMING POLYSILICON LOCAL INTERCONNECTS		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Enclosures	
The following documents are enclosed:	
<input checked="" type="checkbox"/>	An Information Disclosure Statement (1 pg.); Form 1449 (1 pg.), references not enclosed pursuant to 37 C.F.R. 1.98 (a)(2)(i);
<input checked="" type="checkbox"/>	A return postcard.
Please charge any additional fees or credit any overpayments to deposit account 501373.	
CUSTOMER NUMBER: 27073	

Submitted By					
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Signature				Date	1/22/04

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Certificate of Mailing		
I certify that this correspondence and the identified documents are being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 22, 2004.		
Name	Rhonda L. Foley	Signature



First Named Inventor	Chun Chen	INFORMATION DISCLOSURE STATEMENT
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In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Pursuant to 37 C.F.R. 1.98 (a)(2) (i), as this application was filed after June 30, 2003, Applicant has not included copies of U.S. Patents or U.S. Patent Applications. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

As an Office Action has not yet issued in this application, Applicant believes that no fees are due. However, the Commission for Patents is hereby authorized to charge any additional fees to Deposit Account No. 501373. If the Examiner has any questions or concerns regarding this application, please contact the undersigned at the number listed below.

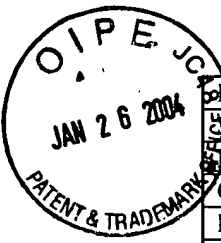
Respectfully submitted,

Date: 1/22/04


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INFORMATION DISCLOSURE
STATEMENT
FORM PTO-1449

Title: METHOD FOR FORMING POLYSILICON
LOCAL INTERCONNECTS

U.S. Patent References				
Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
	20020000423	01/03/2002	Becker	08/06/2001
	5,416,048	05/16/1995	Blalock	04/16/1993
	5,892,285	04/06/1999	Gonzalez	02/19/1997
	5,937,287	08/10/1999	Gonzalez	07/22/1997
	5,945,348	08/31/1999	Blalock	04/04/1996
	6,287,978	09/11/2001	Becker	06/30/1999
	6,337,244	01/08/2002	Prall	03/01/2000
	6,420,250	07/16/2002	Cho	03/03/2000
	6,420,786	07/16/2002	Gonzalez	02/02/1996
	6,501,114	12/31/2002	Cho	08/23/2001
	6,627,913	09/30/2003	Chen	09/10/2001
	6,664,611	12/16/2003	Chen	01/30/2002

Foreign Patent References					
Examiner Initials	Foreign Patent		Name	Publication Date	Translation
	Country	No.			

Other References	
Examiner Initials	Author, Title, Date, Pages, etc.

Examiner Signature		Date Considered	
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			